

PATENT

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: TRAVIS A. LEMKE	Anticipated Examiner: Walker, W
Serial No.: to be assigned	Anticipated Group Art Unit: 1723
Filed: herewith	
For: CONDUCTIVITY FEEDBACK CONTROL PROCESSES FOR SLURRY BLENDING	Docket No. 54197-237098

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Commissioner for Patents
Washington, D.C. 20231

CERTIFY THAT, ON JUNE 7, 2001, THIS PAPER IS BEING DEPOSITED WITH THE UNITED STATES POSTAL SERVICE AS EXPRESS MAIL, POST OFFICE TO ADDRESSEE SERVICE UNDER 37 C.F.R. 1.10 IN AN ENVELOPE ADDRESSED TO THE COMMISSIONER FOR PATENTS, WASHINGTON, D.C. 20231.

Simon Pilbrow

INFORMATION DISCLOSURE STATEMENT

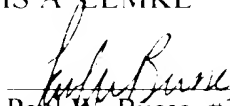
The documents listed on the enclosed Form PTO-1449 are presented pursuant to Applicant's duty of disclosure under 37 C.F.R. § 1.56. These references are of record in the related parent applications. Additional information is set forth in the "Background of the Invention" section of the application.

No fee is believed to be necessary for the entry of this Information Disclosure Statement. Should any fee be required, the Commissioner is authorized to charge our Deposit Account No. 06-0029 and notify us of the same.

Respectfully Submitted,

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INFORMATION DISCLOSURE
STATEMENT BY APPLICANT

Atty. Docket No.	Serial No.
54197-237098	to be assigned
Applicant	
TRAVIS A. LEMKE	
Filing Date	Group
Herewith	

30978 U.S. PTO
09/876459
06/07/01

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
TS	5,755,614	5/1998	Adams et al.			
TS	5,664,990	9/1997	Adams et al.			
TS	5,647,989	7/1997	Hayashi et al.	210	641	
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TS	5,364,510	11/1994	Carpio	204	153.1	
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FOREIGN PATENT DOCUMENTS

Name	Document Number	Date	Country	Class	Subclass	Translation Yes/No
TS	62-11520	10.07.85	Japan			Yes, abstract only
TS	0 605 395	6 July 1994	EP			
TS	0 714 054	29 May 1996	EP			
TS						

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

TS	Philipossian, et al., "An Overview of Current Issues and Future Trends in CMP Consumables," Proceedings of the First CMP-MIC Conference, February 1996, pp. 13-19
TS	J. P. Bare, "Improved Analytical Technique for Metal CMPO Slurry," Proceedings of 2nd CMP-MIC Conference, February 1997, pp. 405-408
TS	Adams, et al., CMP Slurry Reprocessing, 6 pp.

Examiner T. Secher

Date Considered 11/14/02

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation not in conformance and not considered. Include copy of this form with next communication to applicant.

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Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
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TS	4,910,155	3/1990	Cote et al.			
TS	4,382,174	5/1983	Howard-Leicester			
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Name	Document Number	Date	Country	Class	Subclass	Translation Yes/No

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

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T. S. S. S. S.

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